



Docket No.: 52352-372

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Jeffrey A. SHIELDS, et al.	:	Confirmation Number: 8690
	:	
Serial No.: 09/498,336	:	Group Art Unit: 1765
	:	Allowed: May 21, 2004
Filed: February 04, 2000	:	Examiner: V. Perez-Ramos
	:	
For: CF4 + H2O PLASMA ASHING FOR REDUCTION OF CONTACT/VIA RESISTANCE		

LETTER SUBMITTING FORMAL DRAWINGS

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability dated [date_allowed], submitted herewith are three (03) sheets of Formal Drawings in connection with the above referenced application.

Respectfully submitted,

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